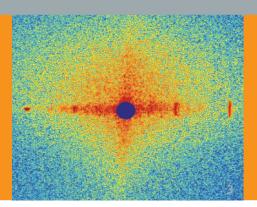
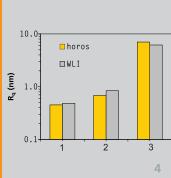


FRAUNHOFER INSTITUTE FOR APPLIED OPTICS AND PRECISION ENGINEERING IOF









- 1 Roughness sensor horos.
- 2 Measurement samples.
- 3 Scatter distribution of diamond turned Al-surface.
- 4 Roughness measurements using horos and WLI (1 Mo/Si-mirror, 2 Ti-coating
- 3 diamond turned Al-surface).

Fraunhofer Institute for Applied Optics and Precision Engineering IOF

Albert-Einstein-Straße 7 07745 Jena

Director

Prof. Dr. Andreas Tünnermann

Department Optical Systems Head of Department Dr. Gunther Notni

Contact

Dr. Angela Duparré Phone +49 3641 807-216 angela.duparre@iof.fraunhofer.de

www.iof.fraunhofer.de

horos COMPACT OPTICAL ROUGHNESS SENSOR

Motivation

Stringent demand for surface characterization techniques that are non-contact, fast, compact, and applicable to a wide range of surface qualities – from machined components to optical surfaces.

Features

- Roughness parameters, PSD, 3D-scattering distribution, isotropy etc.
- Sensitivity: R_a < 0,5 nm
- Measurement time: < 1 s
- Direct link to profilometric techniques

The Sensor

horos (high sensitive optical roughness sensor) is a mobile, light scattering based tool for measuring surface roughness from the micrometer to subnanometer scales.

Applications

Quality control for

- Plane and complex (freeform) surfaces
- Optical fabrication (surface-finishing, coating, molding etc.)
- Mechanical engineering
- Automotive industry